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U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE o a collection of informatic unless it footians a value of the control of Attorney Docket Number Application Data Sheet 37 CFR 1.76 Application Number Not assigned Substrate For Thin-Film Solar Cell, Method For Producing The Same, And Thin-Title of Invention Film Solar Cell Employing It The application data sheet is part of the provisional or nonprovisional application for which it is being submitted. The following form contains the bibliographic data arranged in a format specified by the United States Patent and Trademark Office as outlined in 37 CFR 1.76 This document may be completed electronically and submitted to the Office in electronic format using the Electronic Filing System (EFS) or the document may be printed and included in a paper filed application. Secrecy Order 37 CFR 5.2 Portions or all of the application associated with this Application Data Sheet may fall under a Secrecy Order pursuant to 37 CFR 5,2 (Paper filers only. Applications that fall under Secrecy Order may not be filed electronically.) Applicant Information: Applicant 1 Applicant Authority | | Legal Representative under 35 U.S.C. 117 Party of Interest under 35 U.S.C. 118 Inventor Suffix **Given Name** Middle Name Family Name **Prefix** SASAKI Toshiaki Residence Information (Select One) Active US Military Service US Residency Non US Residency State/Province Country Japan Shiga Citizenship under 37 CFR 1.41(b) Japan Mailing Address of Applicant(s): 2-1-2-131, Hieitsuji Address 1 Address 2 State/Province Shiga City Ohtsu-shi **Country** Japan 520-0104 **Postal Code** All Inventors Must Be Listed – Additional Inventor Information blocks are contained on the attached sheet. **Correspondence Information:** Enter either Customer Number or complete the Correspondence Information section below. For further information see 37 CFR 1.33(a). An Address is being provided for the correspondence information of this application. 26021 **Customer Number** dgadli@hhlaw.com **Email Address** Application Information: Substrate For Thin-Film Solar Cell, Method For Producing The Same, Title of the Invention And Thin-Film Solar Cell Employing It 81844.0052 **Attorney Docket** Small Entity Status Claimed Number **Application Type** Utility **Subject Matter** Sub Class (if any) Suggested Class (if any) Suggested Technology Center (if any) Suggested Figure for Publication (if any) Total Number of Drawing Sheets (if any) | 8

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Application Data Sheet 37 CFR 1.76		Attorney Docket Number	8184	1844.0052					
			Application Number	Not	assigned				
Title of Invention Substrate For Thin-Film Solar Cell, Method For Producing The Same, And Thin-Film Solar Cell Employing It									
Publication Inform	ation	:							
Request Ear	ly Put	olication (Fee required a	t time of Request 37 CFR 1.	.219)					
Request Not to and certify that	Publis the inv	h. I hereby request that the ention disclosed in the attack	attached application not be publis ned application has not been and tilateral agreement, that requires p	hed und will not	be the subject of an				
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information in the Applicat Enter either Customer Nur	ion Data mber or	a Sheet does not constitute a po	s having a power of attorney in the ap ower of attorney in the application (see ame section below. If both sections a ocessing.	e 37 CFI	R 1.32).				
Please Select One: S Customer Number US Patent Practitioner US Representative (37 CFR 11.9)									
Customer Number	26	021							
Domestic Priority	Inforr	nation:							
this information in the	applic	cation data sheet constitut	inder 35 U.S.C. 119(e), 120, 12 es the specific reference required not otherwise be made pa	red by	35 U.S.C. 119(e) or				
120, and 37 CFR 1.78(a)(2) or CFR 1.78(a)(4), and need not otherwise be made part of the specification. Prior Application Status									
Application Numbe	Application Number Continuity Type Prior Application Number Filing Date (YYYY-MI								
This application		National Stage	PCT/JP2005/004543						
Foreign Priority In	forma	ation:							
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the claim for priority a	s requ	ired by 35 U.S.C. 119(b)	and 37 CFR 1.55(a).						
Application Number Country Parent Filing Date (YYYY-MM-DD) Prio					Priority Claimed				
2004-089817		Japan	2004-03-25		Yes No				
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Application Data	Shoot 27 CED 1 76	Attorney Docket Number	81844.0052		
Application Data Sheet 37 CFR 1.76		Application Number	Not assigned		
Title of Invention	Substrate For Thin-Film Solar Cell, Method For Producing The Same, And Th Film Solar Cell Employing It				

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Signature	Daub	/)///	Date (YYYY-MM-DD)	2005-08-09
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This collection of information is required by 37 CFR 1.76. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 23 minutes to complete, including gathering, preparing, and submitting the completed application data sheet form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. **SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450**.

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Substrate For Thin Film S					Application Number				Not assigned		
Title of Invention Substrate For Thin-Film Solar Cell, Method For Producing The Same, And Thin-Film Solar Cell Employing It											
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Applicant	4										
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